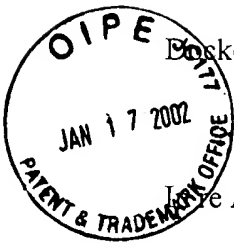


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02-13-02



Packet No.: 61282-017

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventive Application of

Kenji SHIMAZAKI, et al.

Serial No.: 09/993,595

Group Art Unit: 2858

Filed: November 27, 2001

Examiner:

For: METHOD AND APPARATUS FOR ANALYZING ELECTROMAGNETIC  
INTERFERENCE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

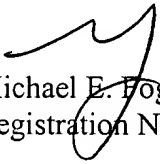
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09/993,595

The relevance of each non-English language reference, and "EMI-Noise Analysis...", is discussed in the present specification.


Respectfully submitted,

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<b>INFORMATION DISCLOSURE</b> <b>CITATION IN AN APPLICATION</b> <div style="text-align: left; margin-top: 10px;">  </div>				ATTY. DOCKET NO. <b>61282-017</b>		SERIAL NO. <b>09/993,595</b>	
(PTO-1449)				APPLICANT <b>Kenji SHIMAZAKI, et al.</b>			
				FILING DATE <b>November 27, 2001</b>		GROUP <b>2858</b>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
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						Yes	No
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	11-200847 •	07/14/1999	Japan (w/ English Abstract)				
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
"EMI-Noise Analysis under ASIC Design Environment", Sachio HAYASHI et al., ISPD 1999, Monterey, California, pp. 16-23 •							
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.